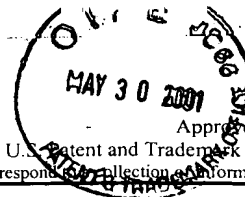


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				Application Number	09/732,927
				Filing Date	December 11, 2000
				First Named Inventor	Nobuo SHIMAZU et al.
				Group Art Unit	Unknown
				Examiner Name	Unknown
Sheet	1	of	1	Attorney Docket Number	740107-135

Examiner Initials*	Cite No. <sup>1</sup>	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code <sup>2</sup> (if known)			
FF		5,831,272		Utsumi	11-03-1998	

Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
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FF		HIGH THROUGHPUT SUBMICRON LITHOGRAPHY WITH ELECTRON BEAM PROXIMITY PRINGING, H. BOHLEN ET AL., SOLID STATE TECHNOLOGY, SEPTEMBER 1984, PAGES 210-217	
108		LOW ENERGY ELECTRON-BEAM PROXIMITY PROJECTION LITHOGRAPHY: DISCOVER OF MISSING LINK, TAKAO UTSUMI, J. VAC. SCI. TECHNOL. B 17(6), NOVEMBER/DECEMBER 1999, PAGES 2897-2902	

Examiner Signature		Date Considered	6-30-02
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